

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Group Art Unit: 1722

Janis Virbulis et al.

Examiner: Matthew J. Song

Serial No.: 10/053,446

Filed: January 17, 2002

For: **PROCESS AND APPARATUS FOR PRODUCING
A SILICON SINGLE CRYSTAL**

Attorney Docket No.: WSAG 0128 PUS

**AMENDMENT UNDER 37 C.F.R. § 1.111
AND PETITION FOR EXTENSION OF TIME
UNDER 37 C.F.R. § 1.136(a)**

Mail Stop Amendment
Commissioner for Patents
U.S. Patent & Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions for a one-month extension of time to respond to the Office Action mailed February 2, 2006, thereby extending the time period within which to respond to June 2, 2006.

In response to the Office Action mailed February 2, 2006, please amend the above-identified application as follows: